

Title (en)
IMPEDANCE MEASUREMENT DEVICES, SYSTEMS, AND METHODS

Title (de)
IMPEDANZMESSVORRICHTUNGEN, -SYSTEME UND -VERFAHREN

Title (fr)
DISPOSITIFS, SYSTÈMES ET PROCÉDÉS DE MESURE D'IMPÉDANCE

Publication
EP 3154427 A4 20180314 (EN)

Application
EP 15806117 A 20150610

Priority

- US 201462011466 P 20140612
- US 201414332140 A 20140715
- US 201414335360 A 20140718
- US 201414338261 A 20140722
- US 201414338266 A 20140722
- US 2015035027 W 20150610

IPC 8 full level
A61B 5/053 (2006.01)

CPC (source: EP KR US)
A61B 5/02125 (2013.01 - KR); **A61B 5/02444** (2013.01 - EP US); **A61B 5/0245** (2013.01 - EP US); **A61B 5/0295** (2013.01 - EP US);
A61B 5/0535 (2013.01 - EP US); **A61B 5/1102** (2013.01 - EP KR US); **A61B 5/25** (2021.01 - KR); **A61B 5/318** (2021.01 - KR);
A61B 5/6829 (2013.01 - EP KR US); **A61B 5/7225** (2013.01 - EP KR US); **G01G 19/50** (2013.01 - EP KR US); **A61B 5/02125** (2013.01 - EP US);
A61B 5/0531 (2013.01 - EP US); **A61B 5/4023** (2013.01 - EP US); **A61B 2562/046** (2013.01 - EP KR US)

Citation (search report)

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- [A] JP 2005230392 A 20050902 - TANITA SEISAKUSHO KK
- [A] EP 1586267 A1 20051019 - TANITA SEISAKUSHO KK [JP]
- See references of WO 2015191670A1

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CN108652608A

Designated contracting state (EPC)
AL AT BE BG CH CY CZ DE DK EE ES FI FR GB GR HR HU IE IS IT LI LT LU LV MC MK MT NL NO PL PT RO RS SE SI SK SM TR

DOCDB simple family (publication)
EP 3154427 A1 20170419; EP 3154427 A4 20180314; JP 2017517373 A 20170629; KR 20170028359 A 20170313

DOCDB simple family (application)
EP 15806117 A 20150610; JP 2017517199 A 20150610; KR 20177000952 A 20150610